

Electronic Patent Application Fee Transmittal				
Application Number:	10813390			
Filing Date:	31-Mar-2004			
Title of Invention:	System and method of removing chamber residues from a plasma processing system in a dry cleaning process			
First Named Inventor/Applicant Name:	Marcel Gaudet			
Filer:	Marvin Jay Spivak/Alexa Ann French			
Attorney Docket Number:	250312US6 YA			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810